



THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 3756**
Tomohiro OKUMURA et al. : Docket No. 2000_0191A
Serial No. 09/511,398 : Group Art Unit 1762
Filed February 23, 2000 : Examiner M. Padgett

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PLASMA PROCESSING METHOD AND
APPARATUS

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Petition hereby is made for a three month extension of time to respond to the communication of
July 2, 2003.

The fee of \$950.00 is

- ☒ (X) submitted herewith.
☐ () to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is
enclosed.
- ☐ () Small entity status of this application is established by a Small Entity Status Assertion
which
☐ () is enclosed.
☐ () has been previously submitted.

Respectfully submitted,

Tomohiro OKUMURA et al.

By

W. Douglas Hahm
Registration No.44,142
Attorney for Applicants

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950.00 OP

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January 2, 2004